

Complete if Known Substitute for form 1449/PTO Application Number 09/759,312 INFORMATION DISCLOSURE Filing Date January 12, 2001 STATEMENT BY APPLICANT First Named Inventor Yoshihiro UETA Art Unit 2812 (Use as many she ets as necessary) S. Mulpuri Examiner Name Sheet 1 1 299002051800 of Attorney Docket Number

U.S. PATENT DOCUMENTS							
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	1.	Zauner, A.R.A. et al. (1999). "Homoepitaxial Growth on Misoriented GaN Substrates By MOCVD," <i>Proceedings of the Material Research Society Symposium W (GaN and Related Alloys) November 28-December 3, 1999</i> , 595:407 (Abstract W6.3).			

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